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CENTRAL FAX CENTER****JUN 16 2006****IN THE UNITED STATES PATENT AND TRADEMARK OFFICE
(Attorney Docket No. 100176)**

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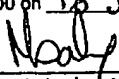
Serial No.: 10/601,601

Filing Date: 06/23/2003

Title: POLISHING PAD FOR
ELECTROCHEMICAL-
MECHANICAL POLISHING

Examiner: Maurina T. Rachuba

Art Unit: 3723

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(Sender's signature)Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450**RESPONSE TO OFFICE ACTION**

This is a reply to the Office Action mailed June 7, 2006 for the above captioned U.S. patent application.

Amendments to the Claims are reflected in the listing of claims that begins on page 2 of this paper.

Remarks begin on page 4 of this paper.

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